



## UNITED STATES PATENT AND TRADEMARK OFFICE

COMMISSIONER FOR PATENTS  
 UNITED STATES PATENT AND TRADEMARK OFFICE  
 WASHINGTON, D.C. 20231  
[www.uspto.gov](http://www.uspto.gov)



B1b Data Sheet

CONFIRMATION NO. 1681

SERIAL NUMBER 09/910,110	FILING DATE 07/20/2001 RULE	CLASS 029	GROUP ART UNIT 3729	ATTORNEY DOCKET NO. 1864 P 071
-----------------------------	-----------------------------------	--------------	------------------------	--------------------------------------

## APPLICANTS

Peter V. Loeppert, Hoffman Estates, IL;  
 Sung Bok Lee, Chicago, IL;

## \*\* CONTINUING DATA \*\*\*\*\*

*None*

## \*\* FOREIGN APPLICATIONS \*\*\*\*\*

*None*

## IF REQUIRED, FOREIGN FILING LICENSE GRANTED

\*\* 09/06/2001

Foreign Priority claimed	<input type="checkbox"/> yes <input checked="" type="checkbox"/> no		
35 USC 119 (a-d) conditions met	<input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance		
Verified and Acknowledged	Examiner's Signature _____ Initials _____		
STATE OR COUNTRY IL	SHEETS 3	TOTAL CLAIMS 20	INDEPENDENT CLAIMS 3

## ADDRESS

Thomas K. Stine  
 Wallenstein & Wagner, Ltd.  
 53rd Floor  
 311 South Wacker Drive  
 Chicago, IL 60606-6630

## TITLE

Raised microstructure of silicon based device

FILING FEE RECEIVED 710 ✓	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue ) <input type="checkbox"/> Other <input type="checkbox"/> Credit
------------------------------	---	---